PATENT	NUMBER	R and
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## U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU		EXAMINER	
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**APPLICANT	Yahiro Y	Takehisa;	<u> </u>				
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Foreign priority of 35 USC 119 con-	ditions met	- <u>-</u> ⊒ y	res ⊒ no				
Verified and Ack	nowledged Examiners's	intials <sup>c</sup> .	na haam blir	-17 ?	1	I-61273	odraphy
TITLE : Methor	ods and devices for	r evaluati	ng seam blur	iii a cha		ticle-beam microlith	
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NOTICE OF ALLOWANCE MAILED			CLAIMS ALLOWED				
		Assistant Examiner	Total Claims		Print Claim for O.G		
ISSUE FEE			DRAWING				
Amount Due	Date Paid		Sheets Drwg.	Figs.Drwg.	Print Fig.		
		Primary Examiner		<u> </u>			
TERMINAL		PREPARED FOR ISSUE	Application Examiner				
	DISCLAMER	WARNING: The information disclosed herein may be restricted. Unsuthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.					
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